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| APPLICANTS: Norifumi Fujimura, Osaka, JAPAN; Ryoma Hayakawa, Osaka, JAPAN; Hiroya Kitahata, Chiba, JAPAN; Tsuyoshi Uehara, Ibaraki, JAPAN; Takuya Yara, Osaka, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/06412 03/25/2005 | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2004-093870 03/26/2004 | | | | |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/08/2007 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY JAPAN | SHEETS DRAWINGS 28 | TOTAL CLAIMS 26 |
| INDEPENDENT CLAIMS 7 | | | | |
| ADDRESS SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES | | | | |
| TITLE Method and apparatus for forming oxynitride film and nitride film, oxynitride film, nitride film, and substrate | | | | |
| FILING FEE RECEIVED 2560 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |